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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: RUSU et al.

Attorney Docket No.:  
LAM1P180/P1170X

Application No.: 10/737,022

Examiner: Unassigned

Filed: December 15, 2003

Group: 1763

Title: HIGH ASPECT RATIO ETCH USING  
MODULATION OF RF POWERS OF VARIOUS  
FREQUENCIES

Confirmation No.: 5595

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on August 1, 2005 in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

*Sue Funchess*

Sue Funchess

**REQUEST FOR STATUS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants hereby request status of the above-referenced patent application. This application was filed on December 15, 2003 and no response has been received as of this date.

Respectfully submitted,

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